



EV Group brings high-speed, high-precision metrology to 3D heterogeneous integration – November 15, 2021

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EV Group today unveiled the EVG 40 NT2 automated metrology system, which provides overlay and critical dimension (CD) measurements for wafer-to-wafer (W2W), die-to-wafer (D2W) and die-to-die (D2D) bonding as well as maskless lithography applications. [More>>](#)

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Business News

[Classiq to collaborate with the Fraunhofer Institute](#)

Classiq, which provides a breakthrough Quantum Algorithm Design platform, announced today that

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Featured Product



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